

Notice of References Cited	Application/Control No. 10/790,244		Applicant(s)/Patent Under Reexamination KWAG ET AL.	
	Examiner Tai Duong		Art Unit 2871	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0085152	07-2002	Chuang et al.	349/123
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	J	US-			
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FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Derwent Abstract 2001-462848 - Abstract Pub. No. KR 2001005217A published 01-2001.
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